Application/Control No.	Applicant(s)/Patent under Reexamination		
10/713,749	YOU ET AL.		
Examiner	Art Unit		
DUNGALE	2818		

SEARCHED					
Class	Subclass	Date	Examiner		
438	197-201	6/28/2005	DLE		
	202-203				
257	343-347				
	330				

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
IEEE, JPO, EPO, PGPUB,IBM, EAST	6/28/2005	DLE		
updated search	3/15/2226	DLE		